5/1/2007

ATTACHMENT 1(a)

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTORNEY DOCKET NO. 1514.1030	APPLICATION NO. 10/734,162
LIST OF REFERENCES CITED BY APPLICANT	FIRST NAMED INVENTOR Ji Yong PARK et al.	
(Use several sheets if necessary)	FILING DATE December 15, 2003	GROUP ART UNIT 2815

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	TRANSLATION YES NO	ABSTRACT
	AG					
	AH					
	AI					
	AJ					
	AK					
	AL					

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

TRANSLATION YES NO

	AM	Office Action issued in Korean Patent Application No. 2002-80326 on November 22, 2004.	X	

EXAMINER	DATE CONSIDERED
	6/29/07

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

5/16/07

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTORNEY DOCKET NO. 1514.1030	APPLICATION NO. 10/734,162
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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
M	AL	2002/0106586	8/2002	You			
M	AM	6,177,301 B1	1/2001	Jung			
M	AN	2002/0100937 A1	8/2002	Yamazaki et al			
M	AO	6,300,175 B1	10/2001	Moon			
	AP						
	AQ						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	TRANSLATION YES NO	ABSTRACT
M	AR	WO 97/45827	12/1997	WIPO		Abstract only
M	AS	GB 2 338 343	12/1999	Great Britain		Abstract only
	AT					
	AU					
	AKV					
	AW					

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

			TRANSLATION YES NO
	AX		

EXAMINER *Mouth C/R*	DATE CONSIDERED 6/29/07

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*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
ᴍ	AA	5,858,823	1/1999	Yamazaki et al.			
ᴍ	AB	2002/0182833 A1	12/2002	Yang			
ᴍ	AC	6,184,541 B1	2/2001	Oka et al.			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	TRANSLATION YES NO	ABSTRACT
ᴍ	AD	EP 1 020 899 A1	7/2000	European		
ᴍ	AE	JP 11-168216	6/1999	Japan		x
ᴍ	AF	JP 11-354800	12/1999	Japan		x
ᴍ	AG	WO 02/09192	1/2002	WIPO		Abstract only
ᴍ	AH	EP 0 565 231 A2	10/1993	European		Abstract only

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

			TRANSLATION YES NO
ᴍ	AI	Search Report issued in corresponding European Patent Application No. 03090437.9-1528 on February 21, 2007	
ᴍ	AJ	Ishihara R et al., "Location Control of Large Grain Following Excimer-Laser Melting of Si Thin-Films", March 1998, Tokyo, Japan, Vol. 37, No. 3B, pages 1071-1075.	
	AK	Office Action issued in corresponding Japanese Patent Application No. 2003-297912 on March 9, 2007.	x

EXAMINER	DATE CONSIDERED
Mauch C Jh	6/29/07

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